Applicants: WATANABE et al

Serial No.: 10/562,207

Filed: December 23, 2005

For: Three-Dimensional Shape Measuring Unit, Processing

Unit, And Semiconductor Device Manufacturing Method

Art Unit:

Examiner:

PRELIMINARY AMENDMENT

September 13, 2006

Mail Stop: Amendment (No Fee) Commissioner For Patents P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

The following amendments are respectfully requested in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendments to the Claims; and

Remarks are included following the amendments.